

*Figure references for Chapter 8*

- Ekin, J. W., Larson, T. M., Bergren, N. F., Nelson, A. J., Swartzlander, A. B., Kazmerski, L. L., Panson, A. J., and Blankenship, B. A. (1988). "High  $T_c$  superconductor/noble-metal contacts with surface resistivities in the  $10^{-10}$   $\Omega\cdot\text{cm}^2$  range," *Appl. Phys Lett.* **52**, 1819–1821.
- Ekin, J. W., Clickner, C. C., Russek, S. E., and Sanders, S. C., (1995). "Oxygen annealing of ex-situ YBCO/Ag thin-film interfaces," *IEEE Trans. Appl. Supercond.* **5**, 2400–2403.
- Kaufman, H. R., and Robinson, R. S. (1989). "Broad-beam ion source technology and applications," *Vacuum* **39**, 1175–1180. Fig. 8.11 reprinted with permission from Elsevier.
- Martin, P. M. (2001). Oak Ridge National Laboratory, Oak Ridge, Tennessee, personal communication.
- Russek, S. E., Sanders, S. C., Roshko, A., and Ekin, J. W. (1994). "Surface degradation of superconducting YBCO thin films," *Appl. Phys. Lett.* **64**, 3649–3651.
- Xu, Y., Ekin, J. W., Clickner, C. C., and Fiske, R. L. (1998). Oxygen annealing of YBCO/gold thin-film contacts," *Adv. Cryog. Eng. (Mater.)* **44**, 381–388.